Sub-Angstrom Characterization of the Structural Origin for High In-Plane Anisotropy in 2D GeS₂

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ABSTRACT: Materials with layered crystal structures and high in-plane anisotropy, such as black phosphorus, present unique properties and thus promise for applications in electronic and photonic devices. Recently, the layered structures of GeS₂ and GeSe₂ were utilized for high-performance polarization-sensitive photodetection in the short wavelength region due to their high in-plane optical anisotropy and wide band gap. The highly complex, low-symmetric (monoclinic) crystal structures are at the origin of the high in-plane optical anisotropy, but the structural nature of the corresponding nanostructures remains to be fully understood. Here, we present an atomic-scale characterization of monoclinic GeS₂ nanostructures and quantify the in-plane structural anisotropy at the sub-angstrom level in real space by Cs-corrected scanning transmission electron microscopy. We elucidate the origin of this high in-plane anisotropy in terms of ordered and disordered arrangement of [GeS₄] tetrahedra in GeS₂ monolayers, through density functional theory (DFT) calculations and orbital-based bonding analyses. We also demonstrate high in-plane mechanical, electronic, and optical anisotropies in monolayer GeS₂ and envision phase transitions under uniaxial strain that could potentially be exploited for nonvolatile memory applications.

KEYWORDS: germanium disulfide, complex 2D material, sub-angstrom imaging, bonding mechanism, in-plane anisotropy

Two-dimensional (2D) materials beyond graphene are under active investigation, as they provide a rich platform to explore intriguing physical phenomena and to achieve applications in multifunctional and flexible devices. As typical 2D semiconductors, transition metal dichalcogenides (TMDCs), such as MoS₂, have a suitable electronic structure and hold great promise for diverse electronic and photonic applications, including field effect transistors, photodetectors, and memory devices. Besides, physical phenomena such as valley polarization and quantum spin Hall effects have also been found in the 2D TMDCs. Similarly, layered main-group chalcogenides based on Ge and Sn have attracted much attention recently, due to their earth-abundant and environmentally friendly nature, thereby promising for sustainable applications.

Elements of the fourth main group in the periodic table form both monochalcogenides and dichalcogenides with layered structures. Both of these families can be physically exfoliated into 2D materials. The ground state of group IV monocalcogenide monolayers, such as GeS, GeSe, SnS, and SnSe, shows a corrugated structure that can be derived from the well-studied black phosphorus monolayer (phosphorene). These materials have been predicted to possess multiferroic properties, with ferroelectric and ferroelastic order occurring simultaneously. Later experiments have demonstrated that the SnTe monolayer is an in-plane ferroelectric material, which shows an unusual thickness scaling behavior. Hence, these materials could potentially be used for future nonvolatile memory and nonlinear optoelectronics (owing to the breaking of centrosymmetry). SnS₂ and SnSe₂ have a simple 1T structure—the central Sn atoms are octahedrally coordinated by six outer S/Se atoms. 2D SnS₂ and SnSe₂ in monolayer or few-layer form have been...
synthesized by chemical vapor deposition and incorporated into devices for various photonics applications.20,21

In comparison with SnS2 and SnSe2, the situation is more complicated for the germanium dichalcogenides, GeS2 and GeSe2. Although monolayers derived from the 1T structure, that is, with octahedral coordination of Ge, have been predicted to be dynamically stable by first-principles calculations,24,25 the ground state of the two compounds favors a layered structure with tetrahedral coordination and much more complex structural patterns, containing 48 atoms in the bulk unit cell (space group P21/c).24,25 In these structures, each layer is composed of eight distorted, edge- and corner-sharing tetrahedral [GeS4] and [GeSe4] motifs in one unit cell. In comparison with rather simple local structural motifs of other 2D layered materials,26 the atomic structure of the monoclinic phase is rather unconventional, making it more difficult to be discovered in automated, high-throughput screening.26 A related case of a highly complex, yet experimentally known and exfoliable structure is given by monoclinic Hittorf’s phosphorus.27

It also remains unclear whether the structurally more complex germanium dichalcogenides can be easily exfoliated into monolayer form, and why such a free monolayer might be preferred over alternatives with structurally more simple arrangements. If this low-symmetric structural pattern can be retained in low-dimensional nanostructures, 2D GeS2 and GeSe2 are expected to show strong in-plane anisotropy in electrical, optical, and mechanical properties.28 Indeed, nanoflakes of GeS2 and GeSe2 with a thickness of 4.2 and 3.5 nm were achieved recently via mechanical exfoliation,29,30 and these materials were used as polarization-sensitive photodetectors in the short wave region, as their band gaps (>2.5 eV) are larger than that of phosphorene (~1.0 eV).14,31

In this work, we carry out direct atomic-scale structural characterization of 2D GeS2 nanostructures by means of Cs-corrected scanning transmission electron microscopy (STEM), allowing us to visualize and quantify the high structural anisotropy of monoclinic (m-) GeS2 in real space. Complementary, dispersion-corrected density functional theory (DFT) calculations suggest a small binding energy between the m-GeS2 layers, corroborating the exfoliable nature of m-GeS2. In addition, our DFT calculations predict high in-plane electrical, optical, and mechanical anisotropies of m-GeS2 in its monolayer form. In comparison with the more symmetric high-pressure phase of GeS2 (HgI2-type),32 we elucidate the origin of the high in-plane anisotropy in the atomic structure and physical properties of m-GeS2 through orbital-based bonding analyses. We also propose potential memory applications of 2D GeS2 under uniaxial strain.

RESULTS AND DISCUSSION

The samples for experimental investigations are powder of m-GeS2 (commercially available at Chengdu Alfa Metal Material Co. Ltd.). Scanning electronic microscopy (SEM) imaging showed that the sample was composed of micrometer-sized particles. Energy-dispersive X-ray (EDX) analysis confirmed the homogeneous elemental distribution of Ge and S and the chemical composition close to the stoichiometry of GeS2 (Figure S1). Figure 1a displays the SEM image of a typical particle. The particle looks compact along the planar directions but shows weakly coupled layers with visible structural gaps along the vertical direction. These observed features are consistent with the crystal structure of m-GeS2 (Figure 1b),24,25 where no strong covalent interactions between the atomic layers can be expected, and with the previously observed cleavage behavior of the material.25 Figure 1b also highlights the [GeS4] tetrahedra as the characteristic building units in the material, which are linked in various ways via corners and edges, and the chemical nature of this linkage will be explored below. Lattice parameters of a = 6.80 Å, b = 16.29 Å, c = 11.68 Å, and β = 91.20° were obtained with dispersion-corrected DFT relaxations, in good agreement with X-ray diffraction experiments.24,25 The calculated energy for exfoliation of m-GeS2 is 11 meV/Å2 (Figure 1c). This value is notably smaller than that for 2H MoS2 (21 meV/Å2),26 indicating the feasibility of exfoliation into monolayers.

The structure of the powder sample is first investigated by electron diffraction analysis. The recorded diffraction pattern along the normal of the a–b plane fits very well to the simulated one based on the DFT-relaxed atomic model of m-GeS2 (Figure S2). To assess the atomic details of the m-GeS2 structure, we carried out STEM characterization on the edge of the m-GeS2 particle, where the thickness was small and suitable for high-resolution STEM investigation. Figure 2a shows the high-angle annular dark field (HAADF) image of m-GeS2 viewed along the normal of the a–b plane. The intensity of the HAADF image is roughly proportional to Z2 (ref 33), where Z represents the average atomic number of the atomic column along the view direction. Since the atomic number of Ge (Z = 32) is much larger than that of S (Z = 16), the bright dots represent the positions of the columns including the Ge atoms. During STEM investigation, effects of beam irradiation damage were observed, which led usually to a local dark contrast of the image (Figure 2a). Such effects are limited in causing any visible change of structural pattern and can be avoided by
adjusting the beam intensity properly (Figure S3). Statistical
STEM investigations confirm that the GeS2 sample is in a
single monoclinic phase (Figures S3 and S4).

Figure 2b shows a zoomed-in HAADF image, which was
averaged along the vertical direction over a damage-free part of
the HAADF image to improve the signal-to-noise ratio and
avoid the effect of beam damage. In most cases, the pure S
atomic columns are invisible due to the very low signal. An
exception are the S columns that have higher atom density and
show faint contrast, as denoted by white arrows in Figure 2b.
From the HAADF image, the structural feature of m-GeS2 can
be considered to be composed of two trapezoid-like building
blocks arranged in opposite directions, which are marked by
the red dashed lines in the image and correspondingly in the
structure model of Figure 2c. In the structure model of Figure
2c, the Ge atoms are accentuated by weakening the symbols of
the S atoms (dashed line circles) for a clear comparison with
the pattern of the HAADF image. Inside a structure block, the
eight prominently bright dots correspond to the eight columns
including Ge atoms. The positions of the S atomic columns are
further confirmed on the annular bright-field (ABF) images
(Figure S5), which reveals positions of both Ge and S atom
columns.

To make a side by side comparison between the HAADF
images and DFT calculations, we performed STEM image
simulations34 based on our DFT-relaxed atomic model. As
shown in the inset of Figure 2b, the simulated HAADF image
appears almost identical with the experimental one. The
simulated image was obtained for a sample thickness of 20 nm.
The typical distances between various Ge columns are given in
the model in Figure 2c. These atomic-scale images
unambiguously verify the in-plane structural anisotropy of m-
GeS2 along the x- and y-directions in low dimension. We
exposed the sample to air for more than 1 year and repeated
the STEM experiments on it. The obtained results
demonstrated the excellent air-stability of m-GeS2.

Next, we performed comprehensive DFT calculations on
monolayer and multilayer 2D GeS2. As shown in Figure 3a, the
relaxed m-GeS2 monolayer retains its bulk structural
parameters with $a_m = 6.80 \, \text{Å}$, $b_m = 16.30 \, \text{Å}$, and $\theta_m = 90^\circ$.
Albeit the monoclinic crystal system refers to three-dimen-

![Figure 2](image1.png)

![Figure 3](image2.png)
sional structures, we denote the resulting structure as the “m-GeS$_2$ monolayer” for the sake of consistency. Our crystal orbital Hamilton population (COHP)\textsuperscript{35–37} chemical bonding analyses support good chemical stability of the m-GeS$_2$: there is no antibonding orbital interaction in the valence bands (Figure 3b). In order to examine the dynamical stability of the monolayer, we performed phonon spectrum calculations and observed no imaginary frequencies (Figure 3c). In addition, we explore its electronic properties by calculating the density of states (DOS) (Figure 3b) and band structure (Figure 3d). We found that the m-GeS$_2$ monolayer is a direct band gap semiconductor. The band gap was calculated to be 2.45 eV using generalized gradient approximation functionals (Figure 3d) and 3.64 eV using hybrid functionals (Figure S6a). The latter value is close to the experimental data (3.71 eV) measured for a 2D nanoflake.\textsuperscript{29} This direct-gap feature is retained in multilayer m-GeS$_2$ up to six-layer thickness in our simulations (Figure S7). Note that the extensively studied direct-gap monolayers, such as MoS$_2$ (\textsim 1.8 eV),\textsuperscript{38} are typically narrow-gap semiconductors (\textsim 2 eV), while m-GeS$_2$ enriches this material class with a much wider band gap.

Since the structural anisotropy in the material arises from the distorted and misaligned [GeS$_4$] tetrahedra, we also consider a possible competing structure of high symmetry: a GeS$_2$ monolayer in which all tetrahedra are connected via corners, resulting in a much more ordered arrangement (Figure 3e). This structure corresponds to a single slab of the high-pressure, layer-structured, tetragonal HgI$_2$-type phase\textsuperscript{52} (Figure S8). We relaxed the simulation cell for this “t-GeS$_2” monolayer while keeping the simple tetrahedral arrangement. The resulting metastable monolayer shows the lattice parameters of $a = b = 3.49$ Å and $\theta = 90^\circ$ and an energy of 36 meV/atom, which is higher (less favorable) than that of the m-GeS$_2$ monolayer. However, the t-GeS$_2$ monolayer is both chemically and dynamically stable, as evidenced by its COHP data (Figure 3f) and phonon dispersions (Figure 3g). The calculated electronic DOS (Figure 3f) and band structure (Figure 3h) suggest t-GeS$_2$ to be an indirect semiconductor with a gap size of 1.42 eV using a gradient-corrected DFT functional and 2.60 eV using a hybrid functional (Figure S6b).

We compare the primitive cell of the m-phase monolayer and a corresponding isomeric 2 × 4 supercell of the t-phase monolayer (Figure 4a). For m-GeS$_2$, all inter-tetrahedral connections along the $x$-axis occur via corner sharing. Along the $y$-axis, in addition to corner-sharing, there are two edges shared by four tetrahedra, namely, the edge between the first and eighth tetrahedra and the one between the fourth and fifth (in the numbering scheme of Figure 4a). The misaligned tetrahedra lead to a slightly reduced lattice parameter by 0.18 Å along the $x$-axis but a much increased value by 2.34 Å along the $y$-axis, which result in a porous structure with ample free volume, making it a suitable candidate for high-performance sodium-ion battery anodes.\textsuperscript{39} The structure of m-GeS$_2$ can, therefore, be seen as related to the SiS$_2$ type\textsuperscript{40} where all tetrahedra share edges, as pointed out by Dittmar and Schäfer.\textsuperscript{25} For t-GeS$_2$, in contrast, all of the tetrahedra are linked by sharing corners.

To understand the bonding mechanisms and to rationalize the energetic stability of the m-phase over the t-phase monolayer, we calculated the degree of charge transfer and the energy-integrated −ICOHPs for individual pairs of neighboring atoms (−ICOHP). These two analysis tools allow us to evaluate the strength of electrostatic and covalent interactions, respectively, in the two monolayers. The Löwdin charge analysis\textsuperscript{41,42} gave almost identical charge transfer in both structures, with charges of about +0.44 e|"−|0.22 e on the Ge/S atoms, respectively, indicating a similar degree of ionic contributions to the bonding. Regarding the covalent character (Figure 4b), all bonds in t-GeS$_2$ are equivalent by symmetry; they therefore have the same length and the same −ICOHP value, and there is therefore only a single blue symbol in the distance-dependent plot of Figure 4b. However, there is a wide range of inequivalent bonds in m-GeS$_2$ and there, the value of −ICOHP changes as a function of bond length (red symbols in Figure 4b). In line with expectation, our analysis reveals the shortest bonds to be strongest; in particular, the −ICOHP values obtained for the shortest bonds indicate higher stabilization than the corresponding values for t-GeS$_2$. These stronger and shorter bonds are found in the denser region of m-GeS$_2$, namely, for the second, third, sixth, and seventh tetrahedra in the labeling scheme of Figure 4a, whereas the weaker and longer bonds appear in the structurally more open area. In short, stronger covalent interactions in the tilted tetrahedra appear to stabilize the m-GeS$_2$ monolayer. This distortion-induced stabilization mechanism is also found in multilayer and bulk phase calculations, and therefore, we conclude that the strong in-plane anisotropy and the porous structure are independent on the film thickness (Figure S9).

The structural complexity of the m-GeS$_2$ monolayer (in particular, the different features in the $x$- and $y$-direction discussed above) results in a strong in-plane anisotropy of various application-relevant physical properties. The ample open area in the monolayer may have direct impact on its mechanical response. In Figure 4, we present the calculated in-plane stiffness $C$ along an arbitrary direction $\theta$ with the following equation:

![Figure 4](https://dx.doi.org/10.1021/acsnano.9b10057)

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The angle made with the positive x-direction in the xy-plane, and $C_{ij}$ are the conventional elastic constants in the Voigt notation. The highest and lowest stiffness values are found along the x- and y-axis, respectively, with $C_{11} = 29.7$ N/m and $C_{22} = 18.6$ N/m, giving a high anisotropy ratio of 1.6. Such a mechanical feature remains in the multilayer form (Figure S10). The small in-plane stiffness of m-GeS$_2$ in particular along the y-axis, suggests the m-GeS$_2$ monolayer to be mechanically rather soft, as compared to the stiffness of the more compact t-GeS$_2$ monolayer (78.5 N/m) and the rigid MoS$_2$ monolayer (180 N/m). Given the presence of similar coordination environments, we speculate that potential phase transitions might take place between the m- and t-phase monolayers through the rearrangement of GeS$_4$ tetrahedra

We also consider the optical absorption anisotropy of the m-GeS$_2$ monolayer. The optical absorbance was calculated from the dielectric function based on the independent particle approximation, using the expression

$$A(\omega) = 1 - \exp\left(-\frac{\omega}{c} e^{(2)} d\right)$$

where $c$ is the speed of light, $e^{(2)}$ is the imaginary part of the dielectric function, and $d$ is the thickness of the simulation cell. As shown in Figure 4d, a clear splitting of optical absorbance appears in the ultraviolet region. We also made an estimate about the optical absorbance of multilayer GeS$_2$, which shows a clear splitting and a high absorption rate of ~80% near the 250 nm wavelength region (Figure S11), comparing well with the device data based on a GeS$_2$ flake of similar thickness (~20 nm). The x- and y-direction absorption spectra indicate the absorption under x-polarized and y-polarized light illumination. In contrast, due to its highly ordered structure, the t-GeS$_2$ monolayer is predicted to show isotropic optical absorbance in the ultraviolet region (Figure S12).

The potential structural transition should also be accompanied by an electronic transition from a direct-gap to an indirect-gap semiconductor with a change in band gap value by 1 eV (Figure 3 and Figure S6), implying a notable change in electrical resistance. Moreover, the transport type should change from anisotropic to isotropic upon such structural transition. Based on the band structure presented in Figure 3d, we calculate the electron/hole effective mass along the $\Gamma-X$ and $\Gamma-Y$ directions according to the top valence band and the bottom conduction band. The results are 0.265 $m_0$ (x-axis) and 1.517 $m_0$ (y-axis) for electrons and 1.126 $m_0$ (x-axis) and 1.736 $m_0$ (y-axis) for holes, giving an in-plane ratio of 5.7 for electrons and 1.5 for holes. Here, $m_0$ is the free electron mass. These data indicate a high in-plane anisotropic charge mobility in the m-GeS$_2$ monolayer. In contrast, for the t-GeS$_2$ monolayer, isotropic charge transport is expected, as the in-plane ratio is calculated to be 1, with an effective mass of 0.338 $m_0$ for electrons and 2.713 $m_0$ for holes.

**CONCLUSION**

In conclusion, we directly visualized the atomic structure of m-GeS$_2$ with sub-angstrom resolution and quantified its structural anisotropy in real space. We elucidated the atomic origin of the complex structural pattern to be the stabilization of chemical bonds upon tilting of the corner-shared GeS$_4$ tetrahedra along the x-axis in the compact segment of the m-GeS$_2$ monolayer. We also predicted high in-plane electrical, optical, and mechanical anisotropies in the m-GeS$_2$ monolayer but isotropic behavior in the t-GeS$_2$ monolayer. A structural transition accompanied by a drastic change in optical and electrical properties is predicted to occur under uniaxial strain due to the small in-plane stiffness of m-GeS$_2$. The tunable electronic structure and optical absorbance may render 2D GeS$_2$ a potential candidate for electronic and optical memory on flexible substrates, enriching the established family of group IV chalcogenides (predominantly, tellurides) that currently employs amorphous-crystalline transitions for memory and photonics applications.

**METHODS**

**Materials and Characterizations.** The TEM and SEM specimens were prepared using a GeS$_2$ powder sample (commercially available from the Chengdu Alfa Metal Material Co. Ltd.). The powder was dispersed into a suspension in ethanol solvent with the help of a KH3200B supersonic cleaner. The suspension was then dropped on the standard TEM copper grids (with a radius of 3 mm) or Si wafers and dried completely. The atomic-resolution HAADF image (Figure S10) was obtained using JEOL ARM200F instrument with probe aberration correctors, operated at 200 keV. The zoomed-in HAADF image was averaged along the vertical direction, and the ABF images were filtered to improve the signal-to-noise ratio. The simulated HAADF and ABF images were carried out using the software packages of Dr. Probe.

The accelerating voltage was set to 200 keV, the aperture radius alpha was 25 mrad, and the detection range of the HAADF detector was 80–350 mrad. The SAED simulations were carried out with CrystalMaker software. The SEM images were observed by a FEI Helios NanoLab DualBeam FIB (focused ion beam) system at 10 kV.

**Computational Methods.** Density functional theory (DFT) calculations were carried out using the Vienna ab initio simulation package (VASP) and Quantum ESPRESSO (QE) package with projector augmented-wave (PAW) pseudopotentials within the generalized gradient approximations (GGA). The electronic, optical, and mechanical property calculations were done by using VASP, while the phonon calculations were conducted by the density functional perturbation theory (DFPT) method implemented in QE. To obtain more accurate bandgap values, the HSE06 hybrid functional calculations were also carried out. For all of the DFT data presented in the main text, GGA functionals were used. van der Waals correction using the DFT-D3 method was included for all calculations. The cutoff energy for plane-wave was set to 520 eV for VASP and 65 Ry for QE. For Monkhorst-Pack k-point meshes, we chose $7 \times 3 \times 4$ for bulk GeS$_2$, $7 \times 3 \times 1$ for monolayer and multilayer monochinic GeS$_2$, and $20 \times 20 \times 1$ for monolayer tetragonal GeS$_2$. We included more than a 20 Å thick vacuum in the z-axis for the monolayer calculations. All structures were relaxed until the force was less than 0.01 eV Å$^{-1}$. The convergence criterion for electronic iterations was $10^{-7}$ eV. Density of states (DOS) and crystal orbital Hamilton population (COHP) analyses were done by the LOBSTER code. The relaxed atomic coordinates of monolayer and bulk GeS$_2$ are included in the Supporting Information. All of the crystal structures were depicted using the VESTA software.

**ASSOCIATED CONTENT**

**Supporting Information**

The Supporting Information is available free of charge at https://pubs.acs.org/doi/10.1021/acsnano.9b10057.
Additional experimental and computational results and supplemental discussion, and relaxed atomic coordinates of structural models (PDF)

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Notes

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